

<b>Notice of References Cited</b>	Application/Control No. 10/799,961		Applicant(s)/Patent Under Reexamination HOFFMAN ET AL.	
	Examiner William Kraig		Art Unit 2815	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,476,788	11-2002	Akimoto, Hajime	345/92
*	B	US-2005/0037237	02-2005	Chen et al.	428/694.00T
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP05-251705	09-1993	Japan	Hamada et al.	
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Phillips et al. ("Transparent Conducting Thin Films of GaInO <sub>3</sub> ", Appl. Phys. Let. Vol. 65 (1), July 1994)
	V	Minami ("Transparent and Conductive Multicomponent Oxide films prepared by magnetron sputtering", Minami, J. Vac. Sci. Technol. A 17(4), Jul/Aug 1999)
	W	D ("Transparent Conducting PbO <sub>2</sub> films prepared by activated reactive evaporation", Phys. Rev. B 33,2660 - 2664 (1986))
	X	Wager ("Transparent Electronics", Science, Vol. 300 (2003))

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.